



1763/8
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Bailey III et al.

Attorney Docket No.: LAM1P123/P0557

Application No.: 09/470,236

Examiner: Alejandro Muler, Jr.

Filed: November 15, 1999

Group: 1763

Title: PLASMA PROCESSING SYSTEM WITH
DYNAMIC GAS DISTRIBUTION CONTROL

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, Washington, DC 20231 on March 3, 2003.

Signed:


Agnes Spence

AMENDMENT TRANSMITTAL

Commissioner for Patents
Washington, DC 20231

Sir:

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	53	MINUS	37	16	x 9 =	x 18 = 288.00
Independent Claims	4	MINUS	3	1	x 42 =	x 84 = 84.00
Multiple Dependent Claim Present and Fee Not Previously Paid					\$140.00	\$280.00
					Total	\$372.00

- Applicant(s) hereby petition for a _____ month extension(s) of time to respond to the aforementioned Office Action.
- Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 500388.
- Enclosed is our Check No. 17926 in the amount of \$372.00 to cover the additional claim fee and/or extension of time fees.
- Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 500388 (Order No. LAM1P123/P0557).

Respectfully submitted,
BEYER WEAVER & THOMAS, LLP


Quin C. Hoellwarth

Reg. No. 45,738

P.O. Box 778
Berkeley, CA 94704-0778



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Examiner: Alejandro Mulero, L.

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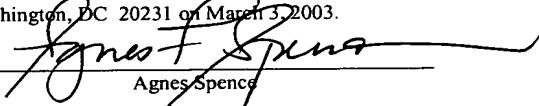
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Patents, Washington, DC 20231 on March 3, 2003.

Signed: 

Agnes F. Spence

AMENDMENT D

#36 F
3/19/03
mw

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In response to the Office Action dated December 5, 2002, please consider the following
amendments and remarks.

03/13/2003 HLE333 00000036 09470236

01 FC:1201 84.00 OP
02 FC:1202 288.00 OP